

## Biography

- Dr. Thomas R. Dietrich, \*April 7, 1961 in Frankfurt , Germany Academic education: Study of Chemistry at Johann-Wolfgang-GoetheUniversity, Frankfurt, Germany  
PhD: "Thin Film Deposition of Amorphous Silicon for Solar Cells" 1991
- Head of the "Photolithography and Etching Processes" group at the Institute of Microtechnology, Mainz (IMM), 1991-1996
- Founder and CEO of mikroglas (since June 1996)
- 2001-17 Chairman of DECHEMA Industry-Plattform "MicroChemTec" and of the ProcessNet Subject Division "Microreaction Engineering"
- Since 2003 Dr. Dietrich gave lectures about "Microchemical Engineering" at the Universities of Appl. Sci. in Kaiserslautern and Bingen, and at the Institute for Separation and Process Technology, TU Clausthal, Germany
- Since 2005 Dr. Dietrich acts as a project leader for several research projects funded by the German government, the European Commission and other organizations on microreaction technology
- 2007 - 2016 Dr. Dietrich was Chairman of the German Standardization Group (DIN) "Microchemical Engineering".
- In 2008 Dr. Dietrich was elected into the Advisory Board of the "Centro Microprocesos Quimicos" at the Tec de Monterrey (ITESM), Mexico
- In June 2008 Dr. Dietrich was the Activity Chairman within the American Institute for Chemical Engineering (AIChE), Process Development Division, "Micro Process Engineering" and its chairman in 2010-11
- Editor of the book "Microchemical Engineering in Practice", ISBN13: 978-0-470-23956-8 - John Wiley & Sons, 2009
- Since January 2014 Dr. Dietrich is the Managing Director of IVAM Microtechnology Network in Dortmund, Germany.
- Dr. Dietrich is member of different boards and organizing committees, e.g. "Nano-in-Germany", "MST-Kongress", "MicroNanoconference"
- Since 2021 Board Member of the Association "Nano in Germany"

## Photo



Logo of the Institution

